

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

CHO ET AL.

Atty. Ref.: 4105-73

Serial No. Unknown

TC/A.U.: Unknown

Filed: February 21, 2006

Examiner: Unknown

For: FERROELECTRIC THIN-FILM PRODUCTION METHOD, VOLTAGE-APPLICATION ETCHING APPARATUS, FERROELECTRIC CRYSTAL THIN-FILM SUBSTRATE, AND FERROELECTRIC CRYSTAL WAFER

* * * * *

February 21, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO/SB/08a. A copy of each listed foreign patent document is attached.

This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO/SB/08a and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By: _____

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ATTY. DOCKET NO.

4105-73

APPLICANT

CHO ET AL.

SERIAL NO. 4

Unknown

10/568770

(Use several sheets if necessary)

FILING DATE

February 21, 2006

TC/A.U.

Unknown

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							TRANSLATION	
DOCUMENT			DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
		2002-501468	1/2002	JP			CLAIMS	
		11-240799	9/1999	JP			ABST	
		2000-196410	7/2000	JP			ABST	

[illegible]

Date Considered